Jung Yeon Park

Khoury College of Computer Sciences, Northeastern University

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Education

Northeastern University

Ph.D. in Computer Science

(Advisor: Lawson Wong, Robin Walters)

Northeastern University

M.S. in Computer Science

KAIST

M.S. in Industrial & Systems Engineering

(Advisor: James R. Morrison)

KAIST

B.S. in Industrial & Systems Engineering

Boston, MA

Boston, MA

2019-present

2022

Daejeon, South Korea

2010

Daejeon, South Korea

2014

Research/Work Experience

Northeastern University, Khoury College of Computer Sciences

Boston, MA 2019-present

Research Assistant

Research areas: Reinforcement learning, Equivariant neural networks, Imitation learning

Samsung Electronics, DS Division

Hwaseong, South Korea

Software Engineer

2016-2019

Developed APIs and client libraries for data extraction. Scaled up big data analytics platform to become largest in semiconductor division. Implemented new ETL pipeline.

KAIST, Department of Industrial & Systems Engineering

Daejeon, South Korea

Graduate Research Assistant

2016-2014

Thesis: Evaluation of Equipment Models of Clustered Photolithography Tools for Semiconductor Fab Simulation

KAIST, Department of Industrial & Systems Engineering

Daejeon, South Korea

Undergraduate Research Assistant

2013

Thesis: Financial Modeling and Simulation of the Case of Diamond Fund

Publications

Publications

Jung Yeon Park and Lawson L.S. Wong. Robust imitation learning of a few demonstrations with a backwards model. In *Advances in Neural Information Processing Systems*, 2022.

Jung Yeon Park*, Ondrej Biza*, Linfeng Zhao, Jan Willem van de Meent, and Robin Walters. Learning symmetric representations for equivariant world model. In *International Conference on Machine Learning*, 2022.

^{*} Equal Contribution

Jung Yeon Park*, Niklas Smedemark-Margulies*, Max Daniels, Rose Yu, Jan-Willem van de Meent, and Paul Hand. Generator surgery for compressed sensing. In *NeurIPS 2020 Workshop on Deep Learning and Inverse Problems*, 2020.

Jung Yeon Park, Kenneth Carr, Stephan Zheng, Yisong Yue, and Rose Yu. Multiresolution tensor learning for efficient and interpretable spatial analysis. In *International Conference on Machine Learning*, pages 7499–7509. PMLR, 2020.

Hyeong-Ook Kim, Se-Hyeon Park, **Jung Yeon Park**, and James R. Morrison. On the consequences of un-modeled dynamics to the optimality of schedules in clustered photolithography tools. In *2019 Winter Simulation Conference (WSC)*, pages 2224–2235. IEEE, 2019.

Jung Yeon Park, Kyungsu Park, and James R Morrison. Models of clustered photolithography tools for fab-level simulation: From affine to flow line. *IEEE Transactions on Semiconductor Manufacturing*, 30(4):547–558, 2017.

Jung Yeon Park, Kyungsu Park, and James R Morrison. Exit recursion models of clustered photolithography tools for fab level simulation. *IEEE Transactions on Semiconductor Manufacturing*, 30(1):39–51, 2016.

Patents

James R. Morrison, **Jung Yeon Park**, Kyungsu Park, and Sang Yoon Bae. An exit recursion model of an apparatus of clustered photolithography for achieving fab(wafer fabrication facilities)-level simulation, and a method for simulating using it. South Korea Patent Office, 1018856190000, July 2018.

James R. Morrison, **Jung Yeon Park**, Kyungsu Park, and Sang Yoon Bae. A model for an apparatus of clustered photolithography for achieving fab(wafer fabrication facilities)-level simulation, and a method for simulating using it. South Korea Patent Office, 1018668570000, June 2018.

Awards and Honors

o Achievement Prize, Samsung Electronics	2017
• Government Scholarship with stipend for M.S.	2014-2016
o Excellence Prize (tied for 1st), KAIST IE Frontier, for undergraduate thesis	2013
Service	
Teaching Assistantship	
CS5335 Robotic Science and Systems: Northeastern University	Spring 2022
CS5180 Reinforcement Learning: Northeastern University	Fall 2021
CS4100 Artificial Intelligence: Northeastern University	Spring 2021
CS7180 Special Topics in Artificial Intelligence: Northeastern University	Fall 2020
Reviewer	
IEEE Robotics and Automation Letters:	2022